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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : Not Yet Assigned
Applicant : Shinji SHIMOSAKI et al.
Filed : Concurrently Herewith
Title : **METHOD FOR FORMING METAL OXIDE COATING FILM AND VAPOR DEPOSITION APPARATUS**
International Application No. : PCT/JP2004/009903
International Filing Date : 06 July 2004
Priority Date(s) Claimed : 10 July 2003

MAIL STOP PCT
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to initial examination, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks begin on page 8 of this paper.